

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number	10764345
	Filing Date	2004-01-23
	First Named Inventor	Tie Liu
	Art Unit	4194
	Examiner Name	DANTE RAVETTI
	Attorney Docket Number	MS1-1811US

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1	Venkatesan, et al., "Robust Image Hashing", Image Processing 2000, Piscataway, NJ USA IEEE, vol. 3, 10 September 2000, pp 664-666.	<input type="checkbox"/>
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